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10/025783

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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10025783	12/26/2001	430	5	1756	

APPLICANTS: Watanabe Miroru;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/443,500 11/19/1999 US 6,372,389

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB <input type="checkbox"/>	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 113 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
Verified and Acknowledged Examiners's initials			MAE 223 C1
TITLE : Method and apparatus for forming resist pattern			
U.S. DEPT. OF COMM./PAT. & TM-PTO-430L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED <i>4-14-03</i>		Assistant Examiner KATHLEEN DUDA PRIMARY EXAMINER <i>Kathleen Duda</i> Primary Examiner	CLAIMS ALLOWED	
Amount Due 0	Date Paid <i>ATT</i>		Total Claims <i>26</i> 24	Print Claim for O.G <i>1</i>
ISSUE FEE		DRAWING		
Amount Due 0	Date Paid <i>ATT</i>	Sheets Drawn <i>4</i>	Figs. Drawn <i>16</i>	Print Fig. <i>2E</i>
TERMINAL DISCLAIMER		S1QS Application Examiner		
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